

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*In re* application of:  
**Aubrey Helms, Jr. et al.**  
Serial No.: 10/519,331  
Filed: April 18, 2005  
For: **Method for Energy-Assisted Atomic Layer Deposition and Removal**

Art Unit: 1792  
Examiner: Stouffer, Kelly M.  
Confirmation No.: 9309  
Atty. Docket No.: 067538-5148-US01

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This amendment is filed in response to the Office Action dated November 12, 2008. Accompanying this amendment is a petition of extension of time bringing the period of response to May 12, 2009. Please consider the following proposed amendments to the above-identified application and the remarks herein.

Please amend the application as follows.

**A Listing of Claims** begin on page 2 of this Amendment.

**Remarks** begin on page 5 of this Amendment.